

DO NOT ENTER: /SM/

03/19/2010

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of	:	Attorney Docket No. 2005_1908A
Tatsuya SASAKI et al.	:	<b>Confirmation No. 7391</b>
Serial No. 10/559,815	:	Group Art Unit 1792
Filed March 23, 2006	:	Examiner Sylvia MacArthur
POLISHING APPARATUS AND POLISHING METHOD	:	<b>Mail Stop: AF</b>

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**AMENDMENT AFTER FINAL REJECTION**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

**RESPONSE UNDER 37 CFR § 1.116  
EXPEDITED PROCEDURE  
EXAMINING GROUP 1792**

Sir:

In response to the Office Action of December 9, 2009, please amend the above-referenced U.S. patent application as follows: